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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Takashi OGAWA :  
Appln. No. [not yet assigned] :  
Filed: August 18, 2006 :  
For: SEMICONDUCTOR INSPECTION :  
METHOD AND SYSTEM :  
THEREFOR : Docket No. S005-5850 (PCT)

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S I R:

Applicant preliminarily amends his application  
before calculation of the filing fee as follows:

**BY EXPRESS MAIL ON AUGUST 18, 2006 (EV 666 011 623 US)**